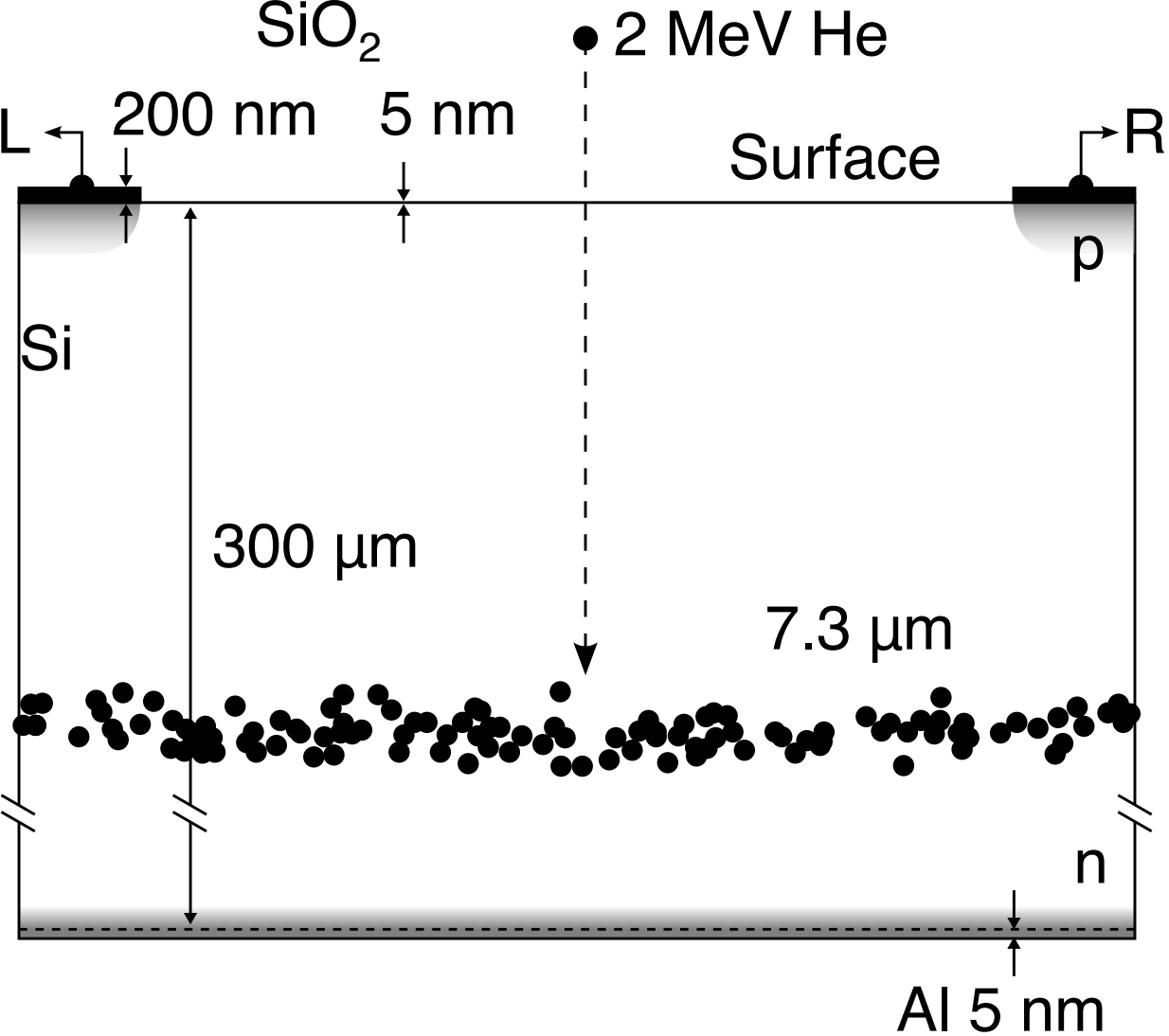

SiO_2
2 MeV He
200 nm
5 nm
L
R
Surface
p
Si
300 µm
7.3 µm
n
Al 5 nm